Applicant : Philip Marriott Serial No. : 09 787,358 : Filed : May 15, 2001

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In the claims:

Please amend claims 1, 13, 15, 16, 19 and 21 as follows:

1. (Currently Amended) A mass spectrometer comprising: means (1) for generating ions from a sample introduced into a plasma;

a sampling aperture (2) for transmitting some of the ions into an evacuated expansion chamber (3) along a first axis (9) to form an ion beam;

a second aperture (5) for transmitting some of the ion beam into a first evacuated chamber (6);

a first pump (7) for maintaining the first evacuated chamber (6) at high vacuum;

a first ion optical device (17) located in the first evacuated chamber (6) for containing the ion beam wherein the first ion optical device (17) is a mass selective device;

a third aperture (19) for transmitting the ion beam into a second evacuated chamber (20);

a second pump (21) for maintaining the second evacuated chamber (20) at a lower pressure than the first evacuated chamber (6);

a collision cell (24) having an entrance aperture (27) and an exit aperture (28) and pressurized with a target gas (26), the collision cell (24) being disposed in the second evacuated chamber (20);

a second ion optical device (25) located in the collision cell (24) for containing the ion beam:

a fourth aperture (32) for transmitting the ion beam into a third evacuated chamber (33) containing mass-to-charge ratio analyzing means (37) disposed along a second axis (36), wherein the mass-to-charge analyzing means is configured to mass analyze for mass analyzing the ion beam to produce a mass spectrum of the ion beam such that both the first ion optical device (17) and the mass-to-charge ratio analyzing means (37) operate at the same mass to charge ratio;

a third pump (39) for maintaining the third evacuated chamber (33) at lower pressure than the second evacuated chamber (20).

2. (Original) A mass spectrometer according to claim 1, wherein the first evacuated chamber (6) is maintained at a pressure of approximately 10^{-2} to 10^{-4} mbar.

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3. (Previously Amended) A mass spectrometer according to claim 1, wherein the first evacuated chamber (6) is maintained at a pressure of approximately $1-2 \times 10^{-3}$ mbar.

- 4. (Previously Amended) A mass spectrometer according to claim 1, including a gap of at least 2 cm between the third aperture (19) and the entrance aperture (27) of the collision cell (24).
- 5. (Previously Amended) A mass spectrometer according to claim 1, wherein the distance between the ion source (1) and the entrance aperture (27) of the collision cell (24) is 90 to 200 mm.
- 6. (Previously Amended) A mass spectrometer according to claim 1, wherein the mass-to-charge ratio analyzing means (37) includes a main mass filter which preferably is an RF quadrupole.
 - 7. (Previously Cancelled)
- 8. (Previously Amended) A mass spectrometer according to claim 1, wherein the first ion optical device (17) is an RF quadrupole.
- 9. (Previously Amended) A mass spectrometer according to claim 1, wherein the second ion optical device (25) is an RF quadrupole.
- 10. (Previously Amended) A mass spectrometer according to claim 1, wherein the second ion optical device (25) is mass selective.
- 11. (Previously Amended) A mass spectrometer according to claim 1, wherein the second axis (36) of the mass to charge ratio analyzing means (37) is offset from the first axis (9).

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12. (Previously Amended) A mass spectrometer according to claim 1, wherein the first evacuated chamber (6) is divided into a first region (14) adjacent to the expansion chamber containing an extractor lens (8) driven at a negative potential, and a second region (15) adjacent to the collision cell (24) in which the ion optical device (17) is located, by a large diameter aperture (11) and the aperture is sealable by means of a flat plate (12) on an O-ring seal (13).

13. (Currently Amended) A method of operating an ICP a mass spectrometer that incorporates a collision cell pressurized with a target gas, the method comprising the steps of: generating, from an ion source, an ion beam including analyte ions and artifact ions; mass selecting at least a portion of the ion beam at an analyte mass to charge ratio; transmitting at least a portion of the mass selected ion beam into the collision cell; inducing collisions between the artifact ions and the target gas in the collision cell transmitting at least a portion of the ion beam from the collision cell to a mass analyzer; and

mass analyzing <u>at least a portion of</u> the <u>ion</u> beam <u>in the mass analyzer</u> at the analyte mass to charge ratio.

- 14. (Previously Added) A method according to claim 13, wherein the mass selecting is achieved by passing the ion beam through a first mass selective ion optical device.
- 15. (Currently Amended) A method according to claim 14, further comprising locating wherein the first mass selective ion optical device is located in a first evacuated chamber maintained at high vacuum.
- 16. (Currently Amended) A method according to claim 15, further comprising locating wherein the collision cell is located in a second evacuated chamber operated at lower pressure than the first evacuated chamber, the ion beam being contained in the second evacuated chamber by a second ion optical device.

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17. (Previously Added) A method according to claim 15, wherein the first evacuated chamber is maintained at a pressure of approximately 10⁻² to 10⁻⁴ mbar.

- 18. (Previously Added) A method according to claim 15, wherein the first evacuated chamber is maintained at a pressure of approximately $1-2 \times 10^{-3}$ mbar.
- 19. (Currently Amended) A method according to claim 16, wherein <u>further</u> comprising transmitting at least a portion of the ion beam, resulting from transmitting some of the ions from the ion source through a sampling aperture into an evacuated expansion chamber along a first axis, is transmitted into the first evacuated chamber through a second aperture, and;

wherein transmitting at least a portion of the mass selected ion beam into the collision cell includes transmitting at least a portion of the ion beam into the second evacuated chamber through a third aperture, and wherein a gap of at least 2 cm is maintained between the third aperture and an entrance aperture of the collision cell.

- 20. (Previously Added) A method according to claim 13, wherein a distance of 90 to 200 cm is maintained between the ion source and an entrance aperture of the collision cell.
- 21. (Currently Amended) A method according to claim 19, further comprising locating a mass-to-charge ratio analyzing means wherein the mass analyzer is located in a third evacuated chamber operated at lower pressure than the second evacuated chamber-and disposing the mass-to-charge ratio analyzing means, the mass analyzer being disposed along a second axis, wherein the mass-to-charge ratio analyzing means includes a main mass filter which preferably is an RF quadrupole.
- 22. (Previously Added) A method according to claim 14, wherein the first mass selective ion optical device is an RF quadrupole.

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23. (Previously Added) A method according to claim 16, wherein the second ion optical device is an RF quadrupole.

- 24. (Previously Added) A method according to claim 16, wherein the second ion optical device is mass selective.
- 25. (Previously Added) A method according to claim 15, wherein the first evacuated chamber is divided into a first region adjacent to the expansion chamber containing an extractor lens driven at a negative potential, and a second region adjacent to the collision cell, by a large diameter aperture and the aperture is sealable by means of a flat plate on an O-ring seal.
- 26. (Previously Added) A method according to claim 21, wherein the second axis is offset from the first axis.

Please add new claim 27 as follows.

-- 27. (New Claim) A mass spectrometer comprising:

an ion source for generating an ion beam from a sample introduced into a plasma;

an ion optical device disposed to receive at least a portion of an ion beam generated by the ion source, the ion optical device being configured to mass select at least a portion of the ion beam generated by the ion source at a mass-to-charge ratio;

a collision cell disposed to receive at least a portion of a mass selected ion beam from the ion optical device; and

a mass analyzer disposed to receive at least a portion of the mass selected ion beam from the collision cell, the mass analyzer being configured to mass analyze the received ion beam at the mass-to-charge ratio.--